

AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1700

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Yeo, *et al.* Docket No.: TSM03-0847  
Serial No.: 10/826,602 Art Unit: 1756  
Filed: April 16, 2004 Examiner: Raymond, Brittany L.  
For: Lithography Apparatus for Manufacture of Integrated Circuits

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 CFR § 1.116**

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated October 2, 2007, which Action is made final. Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of the claims.